

Max Kneiã

List of Publications by Year in descending order

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29
papers

893
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516710

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32
times ranked

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citing authors

#	ARTICLE	IF	CITATIONS
1	Transparent flexible thermoelectric material based on non-toxic earth-abundant p-type copper iodide thin film. <i>Nature Communications</i> , 2017, 8, 16076.	12.8	233
2	Tin-assisted heteroepitaxial PLD-growth of $\text{In}_x\text{Ga}_{1-x}\text{O}_3$ thin films with high crystalline quality. <i>APL Materials</i> , 2019, 7, .	5.1	98
3	Room-temperature Domain-epitaxy of Copper Iodide Thin Films for Transparent CuI/ZnO Heterojunctions with High Rectification Ratios Larger than 109. <i>Scientific Reports</i> , 2016, 6, 21937.	3.3	91
4	Heteroepitaxial growth of $\text{In}_x\text{Ga}_{1-x}\text{O}_3$ phases by metalorganic vapor phase epitaxy. <i>Journal of Crystal Growth</i> , 2019, 510, 76-84.	1.5	59
5	Epitaxial stabilization of single phase $\text{In}_x\text{Ga}_{1-x}\text{O}_3$ thin films up to $x = 0.28$ on c-sapphire and $\text{In}_x\text{Ga}_{1-x}\text{O}_3(001)$ templates by tin-assisted VCCS-PLD. <i>APL Materials</i> , 2019, 7, .	5.1	38
6	Structural, optical, and electrical properties of orthorhombic $\text{In}_x\text{Ga}_{1-x}\text{O}_3$ thin films. <i>APL Materials</i> , 2019, 7, .	5.1	34
7	Epitaxial $\text{In}_x\text{Ga}_{1-x}\text{O}_3$ thin films and heterostructures grown by tin-assisted VCCS-PLD. <i>APL Materials</i> , 2019, 7, .	5.1	30
8	Suppression of Grain Boundary Scattering in Multifunctional p-Type Transparent $\text{In}_x\text{Ga}_{1-x}\text{O}_3$ Thin Films due to Interface Tunneling Currents. <i>Advanced Materials Interfaces</i> , 2018, 5, 1701411.	3.7	26
9	Solubility limit and material properties of a $\text{In}_x\text{Ga}_{1-x}\text{O}_3$ thin film with a lateral cation gradient on $(00.1)\text{Al}_2\text{O}_3$ by tin-assisted PLD. <i>APL Materials</i> , 2020, 8, 021103.	5.1	26
10	A Review of the Segmented-Target Approach to Combinatorial Material Synthesis by Pulsed Laser Deposition. <i>Physica Status Solidi (B): Basic Research</i> , 2020, 257, 1900626.	1.5	26
11	Realization of highly rectifying Schottky barrier diodes and pn heterojunctions on $\text{In}_x\text{Ga}_{1-x}\text{O}_3$ by overcoming the conductivity anisotropy. <i>Journal of Applied Physics</i> , 2021, 130, .	2.5	24
12	Growth, structural and optical properties of coherent $\text{In}_x\text{Ga}_{1-x}\text{O}_3/\text{In}_x\text{Ga}_{1-x}\text{O}_3$ quantum well superlattice heterostructures. <i>APL Materials</i> , 2020, 8, .	5.1	24
13	Control of phase formation of $(\text{Al}_x\text{Ga}_{1-x})_2\text{O}_3$ thin films on c-plane Al_2O_3 . <i>Journal Physics D: Applied Physics</i> , 2020, 53, 485105.	2.8	24
14	Combinatorial Material Science and Strain Engineering Enabled by Pulsed Laser Deposition Using Radially Segmented Targets. <i>ACS Combinatorial Science</i> , 2018, 20, 643-652.	3.8	21
15	Modeling the electrical transport in epitaxial undoped and Ni-, Cr-, and W-doped TiO_2 anatase thin films. <i>Applied Physics Letters</i> , 2014, 105, 062103.	3.3	20
16	Structural and Elastic Properties of $(\text{Al}_x\text{Ga}_{1-x})_2\text{O}_3$ Thin Films on $(11.0)\text{Al}_2\text{O}_3$ Substrates for the Entire Composition Range. <i>Physica Status Solidi (B): Basic Research</i> , 2021, 258, 2000394.	1.5	18
17	Valence band offsets for ALD SiO_2 and Al_2O_3 on $(\text{In}_x\text{Ga}_{1-x})_2\text{O}_3$ for $x = 0.25\text{--}0.74$. <i>APL Materials</i> , 2019, 7, .	5.1	14
18	Band Offsets at $\text{In}_x\text{Ga}_{1-x}\text{O}_3/[\text{Al},\text{In}]_2\text{O}_3/\text{MgO}$ Interfaces. <i>ACS Applied Materials & Interfaces</i> , 2020, 12, 8879-8885.	8.0	14

#	ARTICLE	IF	CITATIONS
19	Band Alignment of Atomic Layer Deposited SiO ₂ and Al ₂ O ₃ on (Al _x Ga _{1-x}) ₂ O ₃ for x = 0.2-0.65. ECS Journal of Solid State Science and Technology, 2019, 8, P351-P356.	1.8	12
20	Strain states and relaxation for α -Al _x Ga _{1-x} O ₃ thin films on prismatic planes of α -Al ₂ O ₃ in the full composition range: Fundamental difference of a- and m-epitaxial planes in the manifestation of shear strain and lattice tilt. Journal of Materials Research, 2021, 36, 4816-4831.	2.6	9
21	Highly transparent conductors for optical and microwave access to spin-based quantum systems. Npj Quantum Information, 2019, 5, .	6.7	8
22	From high-T _c superconductors to highly correlated Mott insulatorsâ€”25 years of pulsed laser deposition of functional oxides in Leipzig. Semiconductor Science and Technology, 2015, 30, 024003.	2.0	7
23	Epitaxial Growth of α -Al _x Ga _{1-x} O ₂ O ₃ Layers and Superlattice Heterostructures up to $x=0.48$ on Highly Conductive Al-Doped ZnO Thin-Film Templates by Pulsed Laser Deposition. Physica Status Solidi (B): Basic Research, 2021, 258, 2000359.	1.5	7
24	Band Offsets of Insulating & Semiconducting Oxides on (Al _x Ga _{1-x}) ₂ O ₃ . ECS Transactions, 2019, 92, 79-88.	0.5	6
25	Effect of Annealing on the Band Alignment of ALD SiO ₂ on (Al _x Ga _{1-x}) ₂ O ₃ for x = 0.2 - 0.65. ECS Journal of Solid State Science and Technology, 2019, 8, P751-P756.	1.8	6
26	Changes in band alignment during annealing at 600â€”C of ALD Al ₂ O ₃ on (In _x Ga _{1-x}) ₂ O ₃ for $x=0.25$ â€”0.74. Journal of Applied Physics, 2020, 127, 105701.	2.5	6
27	Epitaxial growth of rhombohedral $\hat{\Gamma}^2$ - and cubic $\hat{\Gamma}^3$ -CuI. Journal of Crystal Growth, 2021, 570, 126218.	1.5	6
28	Method of full polarization control of microwave fields in a scalable transparent structure for spin manipulation. Journal of Applied Physics, 2020, 128, .	2.5	4
29	Annealing Effects on the Band Alignment of ALD SiO ₂ on (In _x Ga _{1-x}) ₂ O ₃ for x = 0.25â€”0.74. ECS Journal of Solid State Science and Technology, 2020, 9, 045001.	1.8	0